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Complete if Known Substitute for form 1449A/PTO 10/608,287 **Application Number** INFORMATION DISCLOSURE June 27, 2003 Filing Date STATEMENT BY APPLICANT First Named Inventor Yeo, et al. Art Unit 2891 (Use as many sheets as necessary) **Examiner Name** Chaudhari, Chandra P. Sheet 1 of 4 Attorney Docket Number TSM03-0421

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Examiner Initials*	Cite No.1	Document Number  Number - Kind Code <sup>2 (Fknown)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear			
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Substitute for form 1449A/PTO				Complete if Known		
Substitute for form 1449APTO				Application Number	10/608,287	
IN	<b>FORMATIO</b>	N DISCI	OSURE	Filing Date	June 27, 2003	
S	<b>TATEMENT</b>	BY APP	LICANT	First Named Inventor	Yeo, et al.	
				Art Unit	2891	
	(Use as many sheets as necessary)			Examiner Name	Chaudhari, Chandra P.	
Sheet	2	of	4	Attorney Docket Number	TSM03-0421	

			U.S. PATENT	DOCUMENTS		
Examiner nitials*	Cite No.1	Document Number  Number - Kind Code <sup>2 (F known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Whe Relevant Passages or Releva	
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Substitu	ute for form 1449B/PTQ				Complete if Known
				Application Number	10/608,287
INF	ORMATION	DISCL	OSURE	Filing Date	June 27, 2003
	ATEMENT B			First Named Inventor	Yeo, et al.
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Sheet	3	of	4	Attorney Docket Number	TSM03-0421

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
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INF	ORMATION	DISCL	OSURE	Filing Date	June 27, 2003	
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Sheet	4	of	4	Attorney Docket Number	TSM03-0421	

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Examiner Signature	Chandra	Chaudhari	Date Considered	9-05	
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